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SERIAL NUMBER 09/986,743	FILING DATE 11/09/2001 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 740756-2378
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APPLICANTS

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*** CONTINUING DATA *****

This application is a DIV of 09/932,935 08/21/2001 PAT 6,753,212
 which is a DIV of 09/635,422 08/10/2000 PAT 6,730,550

** FOREIGN APPLICATIONS *****

JAPAN 11-229518 08/13/1999
 JAPAN 11-250940 09/03/1999

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged	STATE OR COUNTRY JAPAN SHEETS DRAWING 18 TOTAL CLAIMS 109 INDEPENDENT CLAIMS 30
Examiner's Signature: <i>[Signature]</i> Initials: <i>AC</i>	

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TITLE
 LASER APPARATUS, LASER ANNEALING METHOD, AND MANUFACTURING METHOD OF A SEMICONDUCTOR DEVICE

☐ All Fees